

3/4 (SUN)

Registration 12:30-

Tutorial Plasma Science & Technologies <Chair> T. Shirafuji (Osaka City University)	13:00-14:00 <04pG01TU> Pascal Chabert (LPP,CNRS,Ecole Polytechnique) "Fundamentals of Low-Temperature Plasma Physics."
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Break 14:00-14:15

Tutorial Nitride Semiconductors <Chair> M. Miyoshi (Nagoya Institute of	14:15-15:15 <04pG02TU> Yasushi Nanishi (Ritsumeikan University) "Growth of InN and In-rich InGaN by RF-MBE -Present Status and Challenges-"
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Break 15:15-15:30

Tutorial Nanomaterials <Chair> H. Sato (Mie University)	15:30-16:30 <04pG03TU> Yahachi Saito (Nagoya University) "Carbon Nanomaterials as an Electron Emitter: Fundamentals and Applications"
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Break 16:30-16:45

Tutorial Bioapplications <Chair> K. Niitsu (Nagoya University)	16:45-17:15 <04pG04TU> Pietro Favia (University of Bari) "Tutorial Introduction to Plasma Processing of Biomedical Materials" 17:15-17:45 <04pG05TU> Hajime Sakakita (AIST) "Study on International Standardization of a Low Energy Ionized Gas Haemostasis Equipment"
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Welcome Party
18:00-19:30